





5.0 credits	30.0 h + 30.0 h	2q
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Teacher(s) :	Hackens Benoît ; Francis Laurent ; Raskin Jean-Pierre ;
Language :	Anglais
Place of the course	Louvain-la-Neuve
Inline resources:	https://moodleucl.uclouvain.be/course/search.php?search=LELEC2560
Main themes :	Processing of micro and nanoscopic devices, MEMs, NEMs, and integrated circuits : -- - semiconductor materials and their processing, -- - oxidation, ion implantation ionique, doping, metallisation, plasma... -- - micro & mp; nanolithography, laser machining, etc. -- - micro & mp; nanocharacterisation : SEM, AFM, Ellipsometry, Dektak,...
Aims :	Regarding the learning outcomes of the program of "Master in Electrical Engineering", this course contributes to the development and acquisition of the following learning outcomes : -- AA1.1, AA1.2, AA1.3 -- AA2.1, AA2.2, AA2.3, AA2.4, AA2.5 -- AA3.1 , AA3.2, AA3.3 -- AA4.1, AA4.2, AA4.3, AA4.4 -- AA5.1, AA5.2, AA5.3, AA5.4, AA5.5, AA5.6 -- AA6.1, AA6.3 At the end of this course, students will be able to : -- Design the process of a particular micro & mp; nanoscopic device. -- Use process simulation tools -- Make specific process steps in the clean rooms -- Characterize step results in WinFab and Welcome platforms <i>The contribution of this Teaching Unit to the development and command of the skills and learning outcomes of the programme(s) can be accessed at the end of this sheet, in the section entitled "Programmes/courses offering this Teaching Unit".</i>
Evaluation methods :	Report and oral exam in group
Teaching methods :	A few courses set the ground of major processing techniques. Students then choose a project and design a process based on available informations (iCampus) and bibliography. They interact frequently with a researcher in the field. They finally realize & mp; characterize the designed steps in WinFab and Welcome.
Content :	A first step, using simulation tools, allows students to get familiar with processing and characterization of devices.. A second step, in the clean rooms, give the opportunity to realize a few key processing steps, and characterize them.
Bibliography :	See iCampus course site
Faculty or entity in charge:	ELEC

Programmes / formations proposant cette unité d'enseignement (UE)				
Intitulé du programme	Sigle	Credits	Prerequis	Acquis d'apprentissage
Master [120] in Biomedical Engineering	GBIO2M	5	-	
Master [120] in Chemical and Materials Engineering	KIMA2M	5	-	
Master [120] in Physical Engineering	FYAP2M	5	-	
Master [120] in Electrical Engineering	ELEC2M	5	-	
Master [120] in Electro-mechanical Engineering	ELME2M	5	-	